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CONFIRMATION NO. 5511

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| SERIAL NUMBER 10/551,695 | FILING OR 371(c) DATE 09/30/2005 RULE | CLASS 118 | GROUP ART UNIT 1792 | ATTORNEY DOCKET NO. 061063-0318214 |
| APPLICANTS Yoshinobu Nakada, Ageo-shi, JAPAN; Hiroyuki Shiraki, Ichikawa-shi, JAPAN; Takeshi Hasegawa, Yonezawa-shi, JAPAN; | | | | |
| ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/04508 03/30/2004 | | | | |
| ** FOREIGN APPLICATIONS ***** JAPAN 2003-97365 03/31/2003 | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/10/2006 | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged Examiner's Signature _____ Initials _____ | | STATE OR COUNTRY JAPAN | SHEETS DRAWING 7 | TOTAL CLAIMS 6 |
| | | | | INDEPENDENT CLAIMS 3 |
| ADDRESS 909 | | | | |
| TITLE HEAT TREATMENT JIG AND HEAT TREATMENT METHOD FOR SILICON WAFER | | | | |
| FILING FEE RECEIVED 900 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | |

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